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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
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Patent Application Serial No	10/072,440
Assignee	Micron Technology, Inc.
Examiner	Stephen D. Rosasco
Attorney Docket No	MI22-1829
Attorney Docket No Title: Radiation Patterning Tools, and Method	ls of Forming Radiation Patterning
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Tools	

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

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2. Response to March 12, 2004 Office Action

Dated: <u>June 10, 2004</u>

Bv:

Jénnifer Gaines, Legal Assistant Telephone No. (509) 624-4276 Facsimile No. (509) 838-3424

## FEE DEFICIENCY

Although it is believed that no fees are due, the Commissioner is hereby authorized to charge any fees under 37 C.F.R. 1.16 and 1.17 which may be required by this paper to Deposit Account No. 23-0925.

Dated <u>June 10, 2004</u>

Yi C Latus

David G. Latwesen, Ph.D.

Reg. No. 38,533

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